UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Vignin 22313-1450 www.uspto.gov



Rih Data Shoot

CONFIRMATION NO. 2779

Bib Data Sileet							
SERIAL NUMBEI 10/616,996	FILING DATE 07/11/2003 RULE	CLASS 438		OUP ART UNIT 2813		ATTORNEY DOCKET NO. 2003-0912A	
APPLICANTS							
Hiromi Ogasawara, Miyagi, JAPAN;							
Masashi Takahashi, Miyagi, JAPAN;							
** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
JAPAN 2002-298457 10/11/2002							
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/07/2003							
Foreign Priority claimed 35 USC 119 (a-d) condition	yes no	STATE OR	SHEETS	ТОТ	AL	INDEPENDENT	
met Verified and	Verified and Allowarice		DRAWING			CLAIMS	
Acknowledged /	Examiner's/Signature Ini	tiats JAPAN	3	20)	3	
ADDRESS 000513 WENDEROTH, LIND & PONACK, L.L.P. 2033 K STREET N. W. SUITE 800 WASHINGTON, DC 20006-1021							
TITLE Method of manufacturing a semiconductor element							
		□ _{Al}	☐ All Fees				
	EEC. Authority has been a	ivon in Dane-		1.16 Fees (Filing)			
No.	EES: Authority has been given in Paper lo to charge/credit DEPOSIT ACCOUNT lo for following:					essing Ext. of	
RECEIVED No.	vo for following.			☐ 1.18 Fees (Issue)			
				Other			
1			4 1			11	